## Application Number 10/700,279 INFORMATION DISCLOSURE STATEMENT BY APPLICANT Filing Date November 3, 2003 First Named Inventor Jun Yan Group Art Unit To be Assigned Examiner Name To be assigned Attorney Docket Number MVIS 02-24

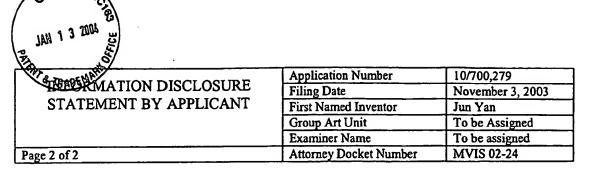
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